

Notice of References Cited	Application/Control No. 09/855,885	Applicant(s)/Patent Under Reexamination LEMEL ET AL.	
	Examiner Kevin M. Nguyen	Art Unit 2674	Page 1 of 1

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*	B	US-6,195,085	02-2001	Becker et al.	345/163
*	C	US-6,618,039	09-2003	Grant et al.	345/168
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*	E	US-2003/0187925	10-2003	Inala et al.	709/204
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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